

Notice of References Cited	Application/Control No. 09/924,787	Applicant(s)/Pat nt Under Reexamination PARK ET AL.	
	Examiner Monica Lewis	Art Unit 2822	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,121,659	09-2000	Christensen et al.	257/347
	B	US-6,156,589	12-2000	Noble	438/149
	C	US-6,476,445	11-2002	Brown et al.	257/347
	D	US-			
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	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	S. Wolf, Silicon Processing for the VLSI Era, 1990, Lattice Press, Volume 2, 318-319.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.